	A I' A' AI	
Notice of Allowability	Application No.	Applicant(s)
	10/632,962	LANGEN, KURT
	Examiner	Art Unit
	Joseph L. Perrin, PhD	1746
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOR (The Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this ap or other appropriate communicatio GHTS. This application is subject	oplication. If not included n will be mailed in due course. THIS
1. X This communication is responsive to continuation filed 30 A	ugust 2005.	
2. The allowed claim(s) is/are 1-6, 8-9 & 11-12 (renumbered a	s claims 1-10 <u>)</u> .	
<ul> <li>3. ☐ Acknowledgment is made of a claim for foreign priority unall</li> <li>a) ☐ All b) ☐ Some* c) ☐ None of the:</li> <li>1. ☐ Certified copies of the priority documents have</li> </ul>		
2.  Certified copies of the priority documents have		
3.  Copies of the certified copies of the priority doc		
International Bureau (PCT Rule 17.2(a)).		3, 4,
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  4.   A SUBSTITUTE OATH OR DECLARATION must be submit	ENT of this application.	
INFORMAL PATENT APPLICATION (PTO-152) which give	s reason(s) why the oath or declar	ation is deficient.
<ol><li>CORRECTED DRAWINGS ( as "replacement sheets") must</li></ol>	be submitted.	
(a) including changes required by the Notice of Draftsperso	on's Patent Drawing Review ( PTO	-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
<ul><li>(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date</li></ul>	Amendment / Comment or in the C	Office action of
Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in th	84(c)) should be written on the drawi e header according to 37 CFR 1.121(	ngs in the front (not the back) of (d).
<ol> <li>DEPOSIT OF and/or INFORMATION about the depos attached Examiner's comment regarding REQUIREMENT F</li> </ol>	it of BIOLOGICAL MATERIAL : OR THE DEPOSIT OF BIOLOGIC	must be submitted. Note the CAL MATERIAL.
·		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. Notice of Informal F	Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🛛 Interview Summary	(PTO-413),
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date</li> </ol>	Paper No./Mail Da s), 7. ⊠ Examiner's Amenda	
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's Stateme	ent of Reasons for Allowance
•	9.	Sthi
		Joseph L. Perrin, PhD Primary Examiner Art Unit: 1746

U.S. Patent and Trademark Office PTOL-37 (Rev. 7-05) Application/Control Number: 10/632,962 Page 2

Art Unit: 1746

## **EXAMINER'S AMENDMENT & STATEMENT OF REASONS FOR ALLOWANCE**

#### Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

- 2. Authorization for this examiner's amendment was given in a telephone interview with Mr. Thomas Perkins on 23 September 2005.
- 3. The application has been amended as follows:

## Claim 1:

In line 12, between "and" and "to divert" insert --having a channel--.

In line 17, after "peripheral edge" insert --, wherein within the defined area, a surface of said gas guide facing the first surface is parallel to the first surface--.

## Cancel claim 10.

# Reasons for Allowance

4. The following is an examiner's statement of reasons for allowance: The closest prior art of record, US 5,769,945 to DAVIS *et al.*, discloses a device having a wafer holding means, a solvent (gas or liquid) dispense means (gas feed means), and an

Application/Control Number: 10/632,962 Page 3

Art Unit: 1746

annular gas guide device having an inner periphery which solvent is drained by the edge of the inner periphery and away from the wafer. The reference does not teach or reasonably suggest a gas guide device in which the gas guide device has a surface parallel to the bottom surface of the wafer near the wafer periphery and the gas guide having a channel or recess, thus enabling cleaning liquid applied above the wafer to wet treat the edge and a defined area of the outer periphery of the bottom surface of the wafer while the gas flushes the inner periphery of the wafer. The edge of the gas guide device functions to form a channel/recess which directs the cleaning liquid and gas downward and away from the wafer between the inner periphery and outer periphery of the wafer in order to wet treat the edge and outer periphery wafer surface while preventing unwanted wet treatment of the inner periphery wafer surface.

#### Conclusion

- 5. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Joseph L. Perrin, PhD whose telephone number is (571)272-1305. The examiner can normally be reached on M-F 7:00-4:30, except alternate Fridays.

Application/Control Number: 10/632,962

Art Unit: 1746

7. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael E. Barr can be reached on (571)272-1414. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

8. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Joseph L. Perrin, PhD Primary Examiner Art Unit 1746 Page 4

jlp